

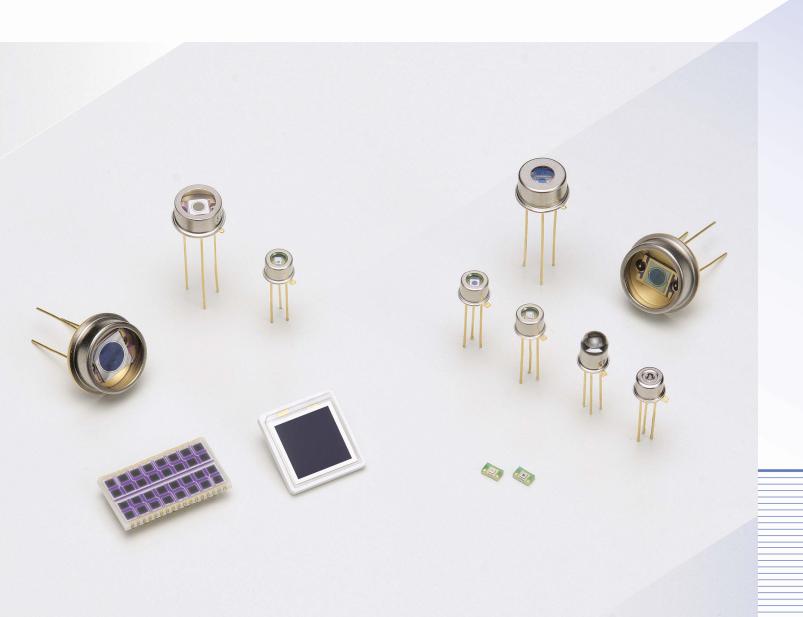
Si APD (avalanche photodiode)

High-speed, high sensitivity photodiodes having an internal gain mechanism



Si APD

High-speed, high sensitivity photodiodes having an internal gain mechanism



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Si APD (avalanche photodiode)

The APD is a high-speed, high-sensitivity photodiode that internally multiplies photocurrent when reverse voltage is applied. The APD, having a signal multiplication function inside its element, achieves higher S/N than the PIN photodiode and can be used in a wide range of applications such as high-accuracy rangefinders and low-light-level detection that use scintillators. Though the APD can detect lower level light than the PIN photodiode, it does require special care and handling such as the need for higher reverse voltage and more detailed consideration of its temperature-dependent gain characteristics.

Si APD

	Туре	Recommended wavelength (nm)	Peak sensitivity wavelength (nm)	Type no.	Package	Features	Applications	Page
	Low-bias operation	200 to 650	50 620 S12053 series, etc. Metal				5	
Short wavelength				S8664-K series	Metal	Enhanced sensitivity in the UV to	Low-light-level detection	
type	Low terminal capacitance	320 to 650	600	S8664-55/-1010	Ceramic	visible region	· Analytical instruments	6
				S8550-02	Ceramic			
	Low-bias operation	600 to 900	800	S12023 series, etc.	Metal	High sensitivity in the near IR region and low bias voltage (operating voltage)	FSOOptical rangefindersOptical fiber communication	
L		000 10 800		S14644 series		Compact, thin, low cost	· Optical rangefinders	
			760	S14643-02	mount type	Compact, thin, low cost, high-speed	· Laser radars · FSO	
Near infrared	Low temperature coefficient	600 to 800	800	S12060 series, etc.	Metal	Low temperature coefficient of the bias voltage, easy gain adjustment	· FSO · Optical rangefinders · Optical fiber communication	9
type	900 nm band,	860 800 to 1000		S12426 series, etc. Metal		Enhanced sensitivity in the 900 nm band	Ontical rangefinders	
	low terminal capacitance		840	S14645-02/-05		Compact, thin	Optical rangefindersLaser radars	10
	Capacitarios	890 to 910	900	S14645-02F/-05F	mount type	Compact, thin, with filter		
	1000 nm band/ high sensitivity	900 to 1150	960	S11519 series	Metal	Enhanced sensitivity in the 1000 nm band, low bias voltage (operating voltage)	· YAG laser detection, etc.	11
	TE-cooled type	400 to 1000	800	S4315 series Meta		High S/N	· Low-light-level detection	

APD modules

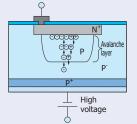
Type	Type no.	Features	Page
Standard type	C12702 series	Contains near infrared type or short wavelength type APD. FC/SMA fiber adapters are also available.	12
High-sensitivity type	C12703 series	High gain type for low-light-level detection	12
High-stability type	C10508-01	Digital temperature compensation type, high stability APD module	12
High-speed type	C5658	Can be used over a wide frequency range (up to 1 GHz)	13

Principle of avalanche multiplication

The photocurrent generation mechanism of the APD is the same as that of a normal photodiode. When light enters a photodiode, electron-hole pairs are generated if the light energy is higher than the band gap energy. The ratio of the number of generated electron-hole pairs to the number of incident photons is defined as the quantum efficiency (QE), expressed in percent (%). The mechanism by which carriers are generated inside an APD is the same as in a photodiode, but the APD is different from a photodiode in that it has a function to multiply the generated carriers.

When electron-hole pairs are generated in the depletion layer of an APD with a reverse voltage applied to the PN junction, the electric field causes the electrons to drift toward the N+ side and the holes to drift toward the P+ side. The higher the electric field strength, the higher the drift speed of these carriers. However, when the electric field reaches a certain level, the carriers are more likely to collide with the crystal lattice so that the drift speed becomes saturated at a certain speed. If the electric field is increased even further, carriers that escaped the collision with the crystal lattice will have a great deal of energy. When these carriers collide with the crystal lattice, a phenomenon takes place in which new electron-hole pairs are generated. This phenomenon is called ionization. These electron-hole pairs then create additional electron-hole pairs, which generate a chain reaction of ionization.

Principle of APD operation



Generated carriers produce new electronhole pairs while being accelerated by high electric field. Ionization

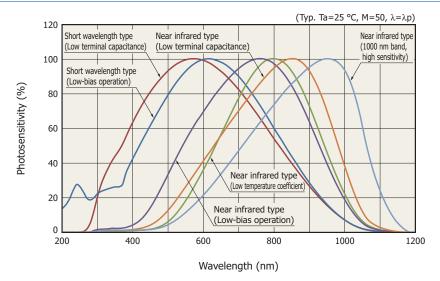


Newly generated carriers are also accelerated to produce further electron-hole pairs, and this process repeats itself. Avalanche multiplication

Gain proportional to the applied reverse bias voltage can be obtained.

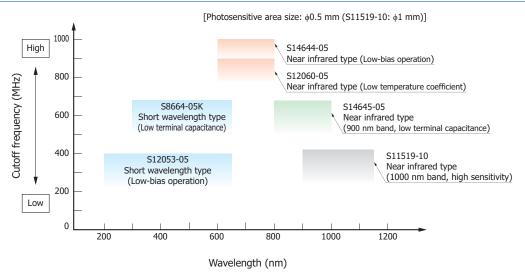
KAPDCOOGEC

Spectral response (Si APD) For the absolute sensitivity values, see the individual datasheets.



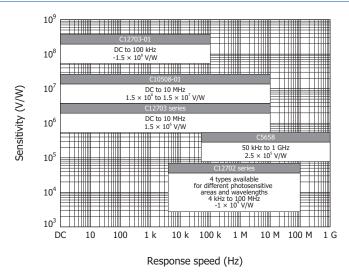
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Cutoff frequency vs. recommended wavelength (typical example)



KAPDB0196EE

Sensitivity vs. response speed (APD modules)



Short wavelength type Si APD

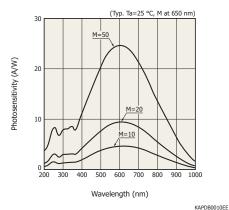
These are short wavelength Si APDs with enhanced sensitivity in the UV to visible region. They offer high gain, high sensitivity, and low noise in the short wavelength region. They are suitable for applications such as low-light-level measurement and analytical instruments.

Low-bias operation

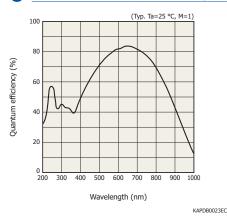
Туре по.	Effective photosensitive area*1 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ² RL=50 Ω (MHz)	Rise time* 2 RL=50 Ω (ns)	Terminal capacitance*2	Gain λ=650 nm		Package
S12053-02	ф0.2				900	0.4	2			
S12053-05	ф0.5				400	0.9	5		TO-18	
S12053-10	ф1.0	200 to 1000	200	0.14	250	1.5	15	50		0
S9075	φ1.5	200 to 1000	200		100	3.5	30	50	TO-5	
S5344	ф3.0				25	14	120		10-5	
S5345	ф5.0				8	45	320		TO-8	

^{*1:} Area in which a typical gain can be obtained

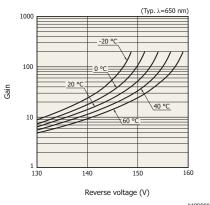
Spectral response



Quantum efficiency vs. wavelength



Gain vs. reverse voltage



KAPDB0011EC

^{*2:} Value obtained when operated at the gain indicated in the table



Low terminal capacitance

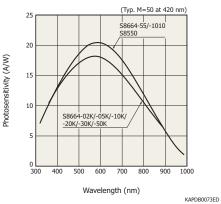
Type no.	Effective photosensitive area*3	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ⁴ RL=50 Ω (MHz)	Rise time* ⁴ RL=50 Ω (ns)	Terminal capacitance*4	Gain λ=420 nm		Package	
S8664-02K	φ0.2	(11111)	(V)	(V / C)	700	0.5	0.8				
S8664-05K	φ0.2				680	0.52	1.6				
S8664-10K	φ1.0				530	0.66	4	T	TO-5		
S8664-20K	φ2.0				280	1.3	11				
S8664-30K	ф3.0				140	2.5	22		TO 0		
S8664-50K	φ5.0	320 to 1000	500	0.78	60	6	55		TO-8		
S8664-55	5 × 5	320 (0 1000			40	9	80	50	Coromio		
S8664-1010	10 × 10				11	32 270 Cera		Ceramic			
S11051-20	ф2.0	266			250	1.4	11		TO-8		

4 × 8 element array

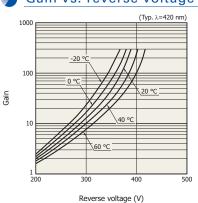
Туре по.	Effective photosensitive area*3 (mm)	Spectral response range (nm)	Breakdown voltage max. (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ⁴ RL=50 Ω (MHz)	Terminal capacitance*4	Gain λ=420 nm		Package
S8550-02	1.6 × 1.6 (x 32 elements)	320 to 1000	500	0.78	250	9 (per element)	50	Ceramic	

^{*3:} Area in which a typical gain can be obtained

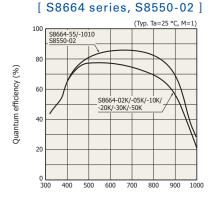
Spectral response



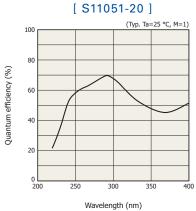
Gain vs. reverse voltage



Quantum efficiency vs. wavelength







KAPDB0374EB

^{*4:} Value obtained when operated at the gain indicated in the table

Near infrared type Si APD

Low-bias operation

These are near infrared Si APDs that operate with low bias voltage. Since high gain can be attained with a bias voltage of 200 V or less, they are suitable for applications such as FSO, laser radar, and optical fiber communication.

Туре по.	Effective photosensitive area*1 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ² RL=50 Ω (MHz)	Terminal capacitance*2	Gain λ=800 nm		Package		
S12023-02	ф0.2				1000	1					
S12023-05											
S12051	ф0.5	φ0.5				900	2		100	TO-18	
S12086							100	10-18			
S12023-10	41.0	400 to 1000	200	0.65	000	C					
S12023-10A	ф1.0				600	6			0		
S3884	φ1.5				400	10	100				
S2384	ф3.0				120	40	60	TO-5			
S2385	ф5.0				40	95	40	TO-8			

Surface mount type

These are low cost, small size Si APDs with a surface-mount plastic package suitable for mass production.

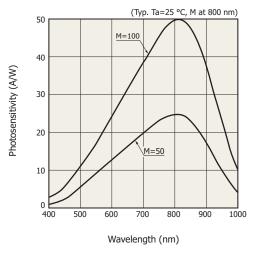
Type no.	Effective photosensitive area*1 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ² RL=50 Ω (MHz)	Terminal capacitance*2	Gain λ=800 nm	Package	
NEW S14644-02	ф0.2	400 to 1000	180	0.63	1200	0.6			
NEW S14644-05	ф0.5			0.03	1000	1.6	100	Plastic	
NEW S14643-02	ф0.2		120	0.42	2000	0.7			

^{*1:} Area in which a typical gain can be obtained

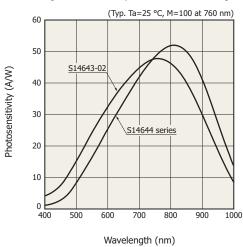
^{*2:} Value obtained when operated at the gain indicated in the table

Spectral response

[S12023 series, S12051, S12086, S3884, S2384, S2385]



[S14643-02, S14644 series]



KAPDB0424EB

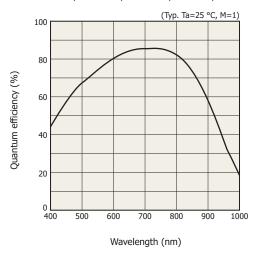
Quantum efficiency vs. wavelength

[S12023 series, S12051, S12086, S3884, S2384, S2385]

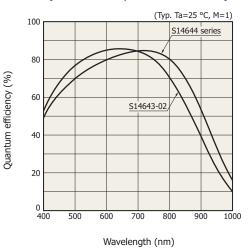
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KAPDB0305EB

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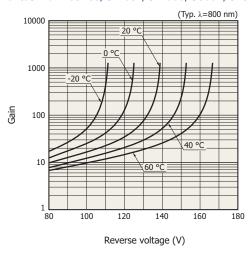
[S14643-02, S14644 series]



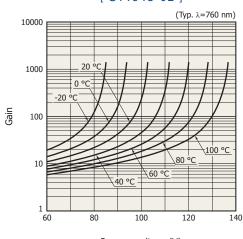
KAPDB0425EB

Gain vs. reverse voltage

[S12023/S14644 series, S12051, S12086, S3884, S2384, S2385]



[S14643-02]



Reverse voltage (V)

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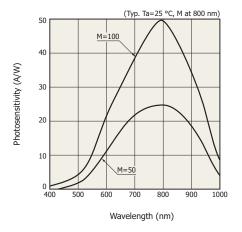
Low temperature coefficient

These are near infrared Si APDs featuring low temperature coefficient of the bias voltage. They produce stable gain over a wide temperature range. They are suitable for applications such as FSO, laser radar, and optical fiber communication.

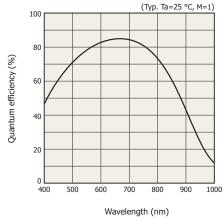
Type no.	Effective photosensitive area*1 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ² RL=50 Ω (MHz)	Terminal capacitance*2	Gain λ=800 nm	Package	
S12060-02	ф0.2				1000	1			
S12060-05	ф0.5		300	0.4	900	2.5	100	TO-18	
S12060-10	ф1.0				600	6			
S6045-04	ф1.5	400 to 1000			350	12	100	TO-5	
S6045-05	ф3.0				80	50	60	10-5	
S6045-06	ф5.0				35	120	40	TO-8	

^{*1:} Area in which a typical gain can be obtained

Spectral response



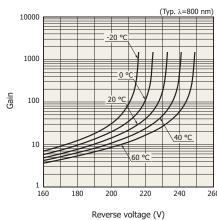
Quantum efficiency vs. wavelength



KAPDB0027EB

KAPDB0026EB

Gain vs. reverse voltage



KAPDB0029EB

^{*2:} Value obtained when operated at the gain indicated in the table



900 nm band, low terminal capacitance

This series is used in laser radar and other applications. It features a gradual curve of gain versus reverse voltage curve, providing stable operation.

Type no.	Effective photosensitive area*3 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ⁴ RL=50 Ω (MHz)	Terminal capacitance*4	Gain λ=900 nm	Package	
S12426-02	ф0.2	400 to 1100	200	1.1	650	0.5		TO-18	
S12426-05	ф0.5	400 to 1100	200	1.1	600	1.1	- 100	10-10	
S9251-10	ф1.0	- 440 to 1100	350	1.85	380	1.9		TO-5	
S9251-15	φ1.5		350		350	3.6		10-5	

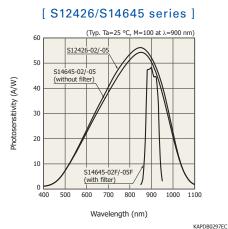
Surface mount type

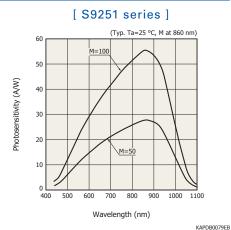
The small, thin leadless package allows reducing the mounting area on a printed circuit board. The S14645-02F and S14645-05F have an on-chip filter matched to a 900 nm light source.

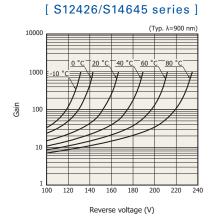
Туре по.	Effective photosensitive area* ³ (mm)	Spectral response range (nm)	Breakdown voltage max. (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ⁴ RL=50 Ω (MHz)	Terminal capacitance*4	Gain λ=900 nm	Package	
NEW S14645-02	*0.2	400 to 1100				0.5			
NEW S14645-02F	ф0.2	850 to 950	195	1.1	600	0.5	100	Plastic	
NEW S14645-05	40 F	400 to 1100	195	1.1	000	1	100	FlaStic	
NEW S14645-05F	ф0.5	850 to 950				1			

^{*3:} Area in which a typical gain can be obtained

Spectral response







Gain vs. reverse voltage

KAPDB0271EA

^{*4:} Value obtained when operated at the gain indicated in the table

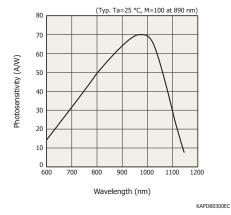
1000 nm band, high sensitivity

The S11519 series incorporates MEMS technology to enhance the sensitivity in the near IR region for YAG laser (1.06 µm) detection.

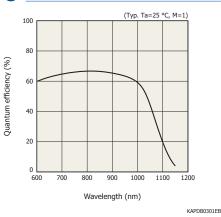
Туре по.	Effective photosensitive area*1 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Temp. coefficient of breakdown voltage (V/°C)	Cutoff frequency* ² RL=50 Ω (MHz)	Terminal capacitance*2	Gain λ=890 nm	Package	
S11519-10	ф1.0	- 600 to 1150	F00	1.7 -	400	2	- 100	TO-5	
S11519-30	ф3.0		500		230	12		TO-8	

^{*1:} Area in which a typical gain can be obtained

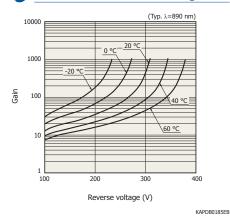
Spectral response



Quantum efficiency vs. wavelength



Gain vs. reverse voltage



TE-cooled type

The S4315 series is a low-bias operation thermoelectrically-cooled type APD capable of high accuracy detection.

Type no.	Cooling temperature ΔT (°C)	Built-in APD	Effective photosensitive area*1 (mm)	Spectral response range (nm)	Breakdown voltage max. ID=100 µA (V)	Cuton	Terminal capacitance*2	Gain λ=800 nm	Package				
S4315		S12023-02	φ0.2	400 to 1000	400 to 1000				1000	1	100		
S4315-01	40	S12023-05	φ0.5			200	900	2	100	TO-8			
S4315-02	40	S12023-10	φ1.0			400 to 1000	400 10 1000		600	6	100	10-6	
S4315-04		S2384	фЗ.О			120	40	60					

^{*1:} Area in which a typical gain can be obtained

^{*2:} Value obtained when operated at the gain indicated in the table

^{*2:} Value obtained when operated at the gain indicated in the table

APD modules

Standard type

The APD module consists of an amplifier and bias power supply assembled in a compact form to facilitate the use of the Si APD. Running on a +5 V power supply, it can be used for a variety of light detection applications up to 100 MHz of frequency bandwidth.

Near infrared type

- Peak sensitivity wavelength: 800 nm
- Wide bandwidth
- Optical fiber adapters are also available. (sold separately).

Applications

- Si APD evaluation
- FSO
- Barcode readers
- Laser radars
- Optical rangefinders
- Optical communication

Type no.	Effective photosensitive area*3 (mm)	Built-in APD	Cutoff frequency		Photoelectric conversion sensitivity M=30, λ=800 nm	Minimum detection limit M=30, λ=800 nm	Temperature stability of gain 25 ± 10 °C (%)	Supply voltage
			Low	High (V/W)	(nW rms)	(V)		
C12702-03	φ1.0	S12023-10	4 kHz	100 MHz	-6.8×10^4	3	±5 max.	. =
C12702-04	ф3.0	S2384		80 MHz	-2.3 × 10 ⁴	3.6		+5

Short wavelength type

Features

- Peak sensitivity wavelength: 620 nm
- Wide bandwidth
- Optical fiber adapters are also available (sold separately).

Applications

- Si APD evaluation
- Film scanners
- Laser monitoring

Type no.	Effective photosensitive area*3 (mm)	Built-in APD	Cutoff frequency		Photoelectric conversion sensitivity M=30, λ=620 nm	$\begin{array}{c} \text{Minimum detection limit} \\ \text{M=30, } \lambda \text{=620 nm} \end{array}$	Temperature stability of gain 25 ± 10 °C	Supply voltage
			Low	High	(V/W)	(nW rms)	(%)	(V)
C12702-11	φ1.0	S12053-10	4 kHz	100 MHz	-2.5×10^4	5	. E may	. 5
C12702-12	ф3.0	S5344	4 KПZ	40 MHz	-1.9 × 10 ⁴	6.3	±5 max.	+5

High-sensitivity type

These are high-gain APD modules suitable for low-light-level detection. They can be used for DC light detection.

Features

- Low-light-level detection
- DC light detection
- High gain

Applications

- Si APD evaluation
- Fluorescence measurement
- Barcode readers
- Particle counters
- Film scanners

Type no.	Effective photosensitive area*3	Internal APD	Cutoff frequency		Photoelectric conversion sensitivity M=30. λ=800 nm	Minimum detection limit M=30, λ =800 nm	Temperature stability of gain 25 ± 10 °C	Supply voltage
	(mm)		Low	High	(V/W)	(nW rms)	(%)	(V)
C12703	φ1.5	S3884	DC	10 MHz	1.5×10^{6}	0.63	ı E may	. 12
C12703-01	φ3.0	S2384		100 kHz	-1.5 × 10 ⁸	0.0063	±5 max.	±12





High-stability type

The C10508-01 consists of an APD, current-voltage converter, high-voltage power supply circuit as well as a microcontroller for adjusting the APD gain and controlling temperature compensation with high accuracy. This makes it easy to adjust the APD gain and even at high gain, stable detection is possible even under temperature fluctuating conditions.

Features

- Gain: adjustable by switch or PC command
- Gain temperature stability: ±5% or less (Gain=250, Ta=0 °C to +40 °C)
- Easy handling: only ±5 V power supply

Applications

- Si APD evaluation
- Power meters
- Low-light-level detection



	Type no.	Effective photosensitive area* (mm)		Cutoff frequency		Photoelectric conversion sensitivity M=250, \(\lambda=800\) nm	Minimum detection limit M=250, λ=800 nm	Temperature stability of gain 0 to 40 °C	Supply voltage
				Low	High	(V/W)	(pW rms)	(%)	(V)
	C10508-01	φ1.0	S12023-10A	DC	10 MHz	1.25×10^{7}	63	±5 max.	±5

FC/SMA fiber adapter (sold separately)

FC or SMA fiber adapters can be attached to the following APD modules to allow FC or SMA optical fiber cables to be connected to the modules.

APD module	FC fiber adapter	SMA fiber adapter
C12702-03	A8407-18	A8424-18
C12702-04	A8407-05A	A8424-05A
C12702-11	A8407-18	A8424-18
C12702-12	A8407-05A	A8424-05A
C12703	A8407-05	A8424-05
C12703-01	A8407-05A	A8424-05A
C10508-01	A12855-01	A12855-02

High-speed type

This device can be used in a wide frequency range (up to 1 GHz).

Features

- High-speed light detection
- Flat frequency characteristics
- Compact and lightweight
- Single power supply operation

Applications

- OTDR
- Optical communication
- Laser radars
- FSO
- Optical rangefinders



Type no.	Effective photosensitive area* (mm)	Internal APD	Cutoff frequency		Photoelectric conversion sensitivity M=100, λ =800 nm	Minimum detection limit $M=100$, $\lambda=800$ nm	Temperature stability of gain 25 ± 10 °C	Supply voltage
			Low	High	(V/W)	(nW rms)	(%)	(V)
C5658	φ0.5	S12023-05	50 kHz	1 GHz	2.50×10^{5}	16	±5	+12

^{*} Area in which a typical gain can be obtained

Disclaimer

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Quality, technology, and service are part of every product.

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